

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Liu et al.

Application No. 10/566,686

Confirmation No. 9220

Filed: March 8, 2007

Art Unit: 1762

For: METHOD AND STRUCTURE OF STRAIN
CONTROL OF SiGe BASED
PHOTODETECTORS AND MODULATORS

Examiner: Not Yet Assigned

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT (SIDS)

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Pursuant to 37 CFR 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached PTO/SB/08. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is filed before the mailing date of a first Office Action on the merits as far as is known to the undersigned.

Applicants submit herewith a copy of the cited non-patent literature in accordance with 37 CFR 1.98(a)(2).

No fees are believed necessary for filing this Supplemental Information Disclosure Statement. However, if any fees are due, the Director is hereby authorized to charge such fees to our Deposit Account No. 07-1700, under Order No. MIT-166.

Dated: August 14, 2008

Respectfully submitted,

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